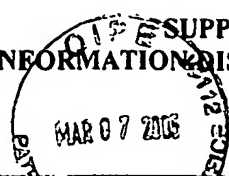

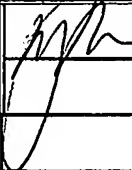


SUPPLEMENTAL INFORMATION DISCLOSURE CITATION 	Docket No.: 0665.016	Application No.: 10/636,101
	Applicant(s): Ramkrishna Ghoshal	Examiner: Moore, M.G.
	Filing Date: August 7, 2003	GAU: 1712

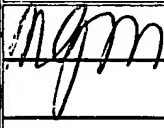
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	AF	5,073,643	12/17/1991	Crivello	556	64	


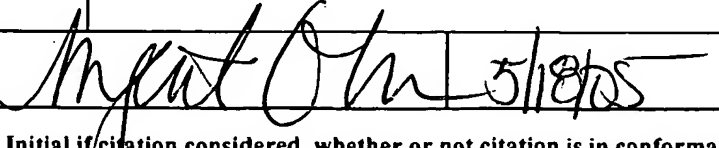
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	BA	US 2002/0193619 A1	12/19/2002	Crivello et al.	556	1	

FOREIGN PATENT DOCUMENTS

Examiner Initial	Ref	Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	CA	WO 98/33645	8/06/1998	PCT	6			

OTHER DOCUMENTS

(Including Author, title, Date, Pertinent Pages, etc.)		
	DA	Crivello, J. V. et al.; "The UV Cure of Epoxy-Silicone Monomers", <i>Polymeric Materials Science and Engineering</i> 60, 217-227 (1989).
EXAMINER:		Date Considered
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		